## **EAST Search History**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S75	1928	(gate or door) adj2 (gasket or o-ring or oring)	US-PGPUB; USPAT	OR	ON	2007/10/28 15:58
S76	10	perfluoroelastomer and (gasket or o-ring or oring) and ((metal or ceramic) adj2 gasket)	US-PGPUB; USPAT	OR	ON	2007/10/28 16:14
S77	1	replac\$5 with frequency with ((metal or ceramic) adj2 gasket)	US-PGPUB; USPAT	OR	ON	2007/10/28 16:29
S78	48	replac\$5 with ((metal or ceramic) adj2 gasket)	US-PGPUB; USPAT	OR	ON	2007/10/28 16:24
S79	16	gasket with replac\$5 with frequency	US-PGPUB; USPAT	OR	ON	2007/10/28 16:24
S80	2	reusable with ((metal or ceramic) adj2 gasket)	US-PGPUB; USPAT	OR	ON	2007/10/28 16:30
S81	1	reusable with ((rubber or elastomer or plastic) adj2 gasket)	US-PGPUB; USPAT	OR	ON	2007/10/28 16:32
S82	5	(resealable or re-sealable) with ((rubber or elastomer or plastic) adj2 gasket)	US-PGPUB; USPAT	OR	ON	2007/10/28 16:32
S83	26111	((elastome\$3 or rubber) and (metal or ceramic)) with (seal or o-ring or oring or gasket)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/10/30 18:33
S84	2815	S83 and (wafer or substrate)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/10/30 18:34
S85	298	S84 and (semiconductor adj ( processing or production or manufacturing or treatment))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/10/30 18:34
S86	8	(nitride with crucible) and (OLED)	US-PGPUB; USPAT	OR	ON	2007/10/31 10:26
S87	100597	frequen\$3 adj3 (open\$3 or replac\$5 or chang\$3 )	US-PGPUB; USPAT	OR	ON	2007/11/13 08:44
S88	839942	door or gate	US-PGPUB; USPAT	OR	ON	2007/11/13 08:52

## **EAST Search History**

S89	1260	S87 with S88	US-PGPUB; USPAT	OR	ON	2007/11/13 08:50
S90	167	S89 and (wafer or substrate)	US-PGPUB; USPAT	OR	ON	2007/11/13 08:54
S91	18	S90 and (semiconductor adj ( processing or production or manufacturing or treatment))	US-PGPUB; USPAT	OR	ON	2007/11/13 08:46
S92	3062	S87 same S88	US-PGPUB; USPAT	OR	ON	2007/11/13 08:52
593	375	S92 and (deposit\$3 or etch\$3 or CVD)	US-PGPUB; USPAT	OR	ON	2007/11/13 08:53
594	271358	door or (gate adj valve)	US-PGPUB; USPAT	OR	ON	2007/11/13 08:52
S95	983	S87 same S94	US-PGPUB; USPAT	OR	ON	2007/11/13 08:52
S96	137	S95 and (deposit\$3 or etch\$3 or CVD)	US-PGPUB; USPAT	OR	ON	2007/11/13 08:53
S97	77	S96 and (wafer or substrate)	US-PGPUB; USPAT	OR	ON	2007/11/13 09:36
S98	67	S97 and (metal or ceramic)	US-PGPUB; USPAT	OR	ON	2007/11/13 09:36
S99	2	S97 and ((metal or ceramic) with (seal or gasket))	US-PGPUB; USPAT	OR	ON	2007/11/13 09:36